



MoO₃/BiVO₄ heterojunction film with oxygen vacancies for efficient and stable photoelectrochemical water oxidation

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ABSTRACT

Poor charge transfer and separation rate are the major bottlenecks for the activity and stability of BiVO₄ photoanode. Here, we introduced oxygen vacancies into MoO₃/BiVO₄ heterojunction film by post-annealing the film in argon-saturated environment for improving its photoelectrochemical (PEC) water oxidation activity and stability. In comparison with the normal MoO₃/BiVO₄ film, the MoO₃/BiVO₄ film with oxygen vacancies is of better PEC water oxidation performance. Specifically, a higher photocurrent density of 4.1 mA/cm² in 0.1 M Na₂SO₄ at 1.1 V versus SCE was achieved on the MoO₃/BiVO₄ film with oxygen vacancies, which is about 200% improved over the normal MoO₃/BiVO₄ film (1.83 mA cm⁻², at 1.1 V versus SCE). In addition, the MoO₃/BiVO₄ film with oxygen vacancies shows more stable activity and faster kinetics for water oxidation, without significant activity loss for 5 h reaction at 1.23 V versus RHE. The enhanced performance on such a MoO₃/BiVO₄ film photoanode can be attributed to that the oxygen vacancies accelerate the charge transfer and separation rate between film/electrolyte interface, and thus improve the water oxidation activity and restrain the anodic photocorrosion simultaneously.

Introduction

In recent years, BiVO₄ has been widely studied as one of the most promising photoanode materials for photoelectrochemical (PEC) water splitting [1]. The

advantages of BiVO₄ for PEC water splitting can be generalized as follows: First, BiVO₄ is of suitable band gap (~ 2.4 eV); thus, it can absorb about 11% light from the solar spectrum [2]. Second, the valence band of BiVO₄ is located at a more positive potential (~ 2.40 V versus RHE) than the water

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oxidation potential (1.23 V versus RHE), allowing for solar water oxidation [3]. And third, the raw materials for the production of BiVO₄ photoanode are in abundance and of low cost. Under standard AM 1.5 G solar light irradiation, a theoretical photocurrent of 7.6 mA/cm² can be obtained on BiVO₄ photoanode with a high solar-to-hydrogen conversion efficiency (η_{STH}) of 9.3% [4, 5], very close to the η_{STH} of commercial requirement for PEC water splitting (10%). Unfortunately, the actual water oxidation activity on BiVO₄ photoanode was impeded by its poor charge transport and separation property [1, 6]. In addition, the photostability of BiVO₄ was suffered from anodic photocorrosion that involves the loss of V⁵⁺ ions from BiVO₄ lattice by dissolution [7]. Therefore, the modifications of BiVO₄ activity and stability are the forefront of PEC water splitting field.

In general, the charge transport property of BiVO₄ is related to its composition and morphology, and the separation property of BiVO₄ was affected by its surface feature. Accordingly, composition and morphology tuning are developed as two effective strategies in recent years for addressing the charge transport issue of BiVO₄. Typically, W and Mo co-substituting the partial sites of V in BiVO₄ that could improve the conductivity of BiVO₄ and introduce polarons into BiVO₄ lattice, and thus, enhanced bulk charge migration property is observed on W and Mo co-doped BiVO₄ photoanode [8, 9]. Furthermore, proper oxygen evolution catalysts or photocatalyst couplings have been demonstrated to be effective approaches for improving the charge separation property of BiVO₄. For example, FeOOH or Co-Pi (Cobalt-Phosphate) coated on BiVO₄ is capable of enhancing the separation of photo-generated holes and electrons on BiVO₄ surface [10, 11]. Owing to the matched band potentials between WO₃ and BiVO₄, WO₃/BiVO₄ heterojunction photoanode is of higher charge separation efficiency through the physical separation of surface charge [12]. On the other side, BiVO₄ is not thermodynamically stable enough against photocorrosion, which is the primary cause of BiVO₄ anodic photocorrosion. In the work of Bard et al., an inert layer of amorphous TiO₂ coupled on BiVO₄ film shows the function of protecting BiVO₄ from photocorrosion via changing the oxidation state at BiVO₄/electrolyte interface [13]. Additionally, Choi et al. reported the use of a V⁵⁺-saturated electrolyte that can inhibit the photooxidation-coupled dissolution of BiVO₄ photoanode [7]. Significantly,

the degree of BiVO₄ anodic photocorrosion critically depends on the relative rate of photocorrosion compared with the rates of interfacial charge transfer and surface charge separation [7, 10]. It reveals that when the BiVO₄ photoanode has faster interfacial charge transfer rate or surface charge separation rate than its photocorrosion rate, the BiVO₄ anodic photocorrosion can be kinetically suppressed. In summary, both the PEC activity and stability of BiVO₄ are determined by its charge transfer and separation properties. It is noteworthy that the reported works mainly focus on the modification of individual property of BiVO₄ (activity or stability), few regard to the improvements of PEC activity and stability simultaneously.

Both experimental and calculational works have revealed that oxygen vacancies can effectively modulate the electronic properties of photocatalysts, and thus improve their bulk charge transport and surface separation efficiency [14]. Normal BiVO₄ is of poor PEC activity due to its low carrier mobility of ~ 0.044 cm²/V s [15], while BiVO₄ with oxygen vacancies shows much higher PEC activity [16], indicating higher carrier mobility in BiVO₄ with oxygen vacancies. As remarkable charge transfer material, MoO₃ with oxygen vacancies possesses high carrier mobility up to 1100 cm²/V s [17]. Interestingly, the band potentials between MoO₃ and BiVO₄ are favorable to separate the surface charge of BiVO₄ [18]. Inspired by this information, MoO₃/BiVO₄ heterojunction photoanode with oxygen vacancies is expected to have high water oxidation activity and stability. The bulk charge transport in BiVO₄, surface charge separation on BiVO₄, and the charge transfer and separation between BiVO₄ and MoO₃ interface all can be improved by the oxygen vacancies effect in theory.

Herein, oxygen vacancies were introduced into the MoO₃/BiVO₄ heterojunction film by post-annealing the film in argon-saturated environment. Subsequently, the MoO₃/BiVO₄ film with oxygen vacancies was investigated as photoanode for water oxidation. Due to the existence of oxygen vacancies in MoO₃ and BiVO₄, a high photocurrent density of 4.1 mA/cm² was achieved on the MoO₃/BiVO₄ photoanode in 0.1 M Na₂SO₄ at 1.1 V versus SCE under irradiation of simulated solar light (100 mW/cm²). Additionally, the MoO₃/BiVO₄ film photoanode with oxygen vacancies shows high stability for

water oxidation, without significant loss of photoactivity for 5 h reaction.

Experimental section

Material synthesis

The $\text{MoO}_3/\text{BiVO}_4$ heterojunction film with and without oxygen vacancies was prepared using a drop-casting method on FTO glass substrate as described in our previous work with annealing modifications [18, 19]. Firstly, $\text{Bi}(\text{NO}_3)_3 \cdot 5\text{H}_2\text{O}$ (Aladdin, 99.0%) was dissolved in a solvent containing concentrated HNO_3 (Aladdin, 68%) and ethylene glycol (EG, Aladdin) to form a Bi precursor solution of 25 mM. NH_4VO_3 (Sigma-Aldrich, 97%) was dissolved in EG as V precursor solution with a concentration of 25 mM. Molybdenum powder (Aladdin, 99.9%) was firstly dissolved in H_2O_2 (Aladdin, 30 wt%) and then mixed with EG to form 5 mM Mo precursor solution. Secondly, the V and Bi precursor solutions were mixed with same volume for the preparation of BiVO_4 film. 20 μL of mixed precursor solution was dropped on the FTO glass substrate (1.0 cm \times 1.5 cm, sheet resistance $< 15 \Omega$) that had been cleaned and sonicated with distilled water and ethanol. Next, the mixed precursor solution on FTO glass was dried at 150 $^\circ\text{C}$ for 60 min and then annealed at 500 $^\circ\text{C}$ for 120 min in air to form a BiVO_4 film. Finally, 10 μL of Mo precursor was dropped on the BiVO_4 film and then annealed at 500 $^\circ\text{C}$ for 120 min in air to form the $\text{MoO}_3/\text{BiVO}_4$ heterojunction film. For the introduction of oxygen vacancies, the $\text{MoO}_3/\text{BiVO}_4$ heterojunction film was further annealed at 400 $^\circ\text{C}$ for 40 min in an argon-saturated environment and then be marked as $\text{MoO}_3/\text{BiVO}_4$ (Ar). Based on subsequent PEC measurements, such an annealing condition was regarded as the optimal after investigating various annealing temperatures and time (temperature: 350 $^\circ\text{C}$, 400 $^\circ\text{C}$ and 450 $^\circ\text{C}$; time: 20 min, 40 min, 60 min and 100 min). For comparison, the BiVO_4 and MoO_3 films were treated using the same post-annealing condition in argon-saturated environment and then be marked as $\text{BiVO}_4(\text{Ar})$ and $\text{MoO}_3(\text{Ar})$, respectively. In addition, $\text{MoO}_3/\text{BiVO}_4(\text{O}_2)$ film was prepared via post-annealing the $\text{MoO}_3/\text{BiVO}_4$ film in O_2 -saturated atmosphere at 500 $^\circ\text{C}$ for 2 h.

Material characterization

Scanning electron microscopy (SEM, Zeiss Supra 55 VP) and transmission electron microscope (TEM, JEOL, JEM-2010) were used to observe the morphology and microstructure of the as-prepared films. X-ray diffraction (XRD) patterns of the as-prepared films were recorded on a PANalytical X'pert PRO diffractometer equipped with Cu-K α radiation at a scanning rate of 2 $^\circ$ /min. Chemical state and compositions of the as-prepared films were characterized using X-ray photoelectron spectroscopy (XPS, ESCALAB 250, Thermo Scientific). UV-Vis absorption spectrum was collected on a Shimadzu UV-2600/2700 spectrophotometer. The Raman spectrum was measured using a Renishaw in Via Raman microscope with 514.5 nm argon ion laser. The electron paramagnetic resonance (EPR) measurements were taken on Bruker EMX-plus operating in the X-band (9.52 GHz) with a microwave power of 2 mW. The content of V in the electrolyte (0.1 M Na_2SO_4) that was used for PEC stability testing was measured by inductively coupled plasma technique (ICP, Thermo ICAP6300 Duo).

Electrochemical and photoelectrochemical measurements

The electrochemical and photoelectrochemical measurements were taken in a three-electrode cell (quartz cube cup, 5.0 \times 5.0 \times 5.0 cm^3). The as-prepared films with an area of 1.0 cm^2 were used as working electrode. The counter electrode was a Pt wire with a diameter of 0.5 mm (99.99%, CHI Instrument), and the reference electrode was saturated calomel electrode (SCE, Shanghai INESA Scientific Instrument). 0.1 M Na_2SO_4 was mainly employed as the electrolyte for electrochemical and photoelectrochemical measurements. The pH of electrolyte was checked using a benchtop pH meter (PHS-3C, Shanghai INESA Scientific Instrument). A CH Instruments 660E electrochemical workstation was used for electrochemical and photoelectrochemical measurements.

The irradiation source was a 300 W xenon lamp with AM 1.5G filter (Beijing China Education Au-light Co., Ltd.). For light measurements, the lamp was positioned to provide irradiation of 100 mW/cm^2 on the films. The light irradiation power was measured by a thermopile detector (Beijing China Education Au-light Co., Ltd.). The

photoelectrochemical measurements of the films were mainly conducted using back-side irradiation (through the FTO glass substrate to the film). IPCE measurements were taken using a full solar simulator (Beijing China Education Au-light Co., Ltd. 300 W xenon lamp) with an AM 1.5 filter and a motorized monochromator (Oriel Corner-stone 130 1/8 m). A typical monochromatic light used for the IPCE measurements can be found in Fig. S8. Light power was measured using a handheld optical power meter with a UV enhanced silicon photodetector (Newport, Models 1916C and 818-UV). The IPCE is expressed by following equation:

$$\text{IPCE} = (1240 \times j) / (\lambda \times P_{\text{light}}) \quad (1)$$

where j is the measured photocurrent density at a specific wavelength (mA cm^{-2}), λ is the wavelength of incident light (nm), and P_{light} is the measured light power density at that wavelength (mW/cm^2).

The electrochemical impedance spectroscopy (EIS) was performed in 0.1 M Na_2SO_4 solution under irradiation (100 mW/cm^2) at 1.23 V versus RHE with an AC amplitude of 5 mV, frequency of 10 mHz–100 kHz. Zview software was used to fit the measured EIS spectrum and get the equivalent circuit. To convert the potential (versus SCE) to RHE (NHE at pH 0), the following equation was used.

$$E_{\text{RHE}} = E_{\text{SCE}} + 0.0591 \text{pH} + E_{\text{SCE}}^{\theta} (E_{\text{SCE}}^{\theta} = 0.2415 \text{ vs. NHE at } 25^{\circ}\text{C}) \quad (2)$$

Mott–Schottky measurements were taken in 0.1 M Na_2SO_4 solution using an impedance versus applied potential method at a frequency of 1000 Hz. Mott–Schottky plots were created and fitted to ideal semiconductor behavior:

$$1/C^2 = (2/e\epsilon\epsilon_0 A^2 N_d) (V_a - V_{\text{fb}} - kT/e) \quad (3)$$

here C is the space charge layer capacitance, ϵ is the relative dielectric constant, ϵ_0 is the permittivity of free space, e is the elemental charge, A is the surface area of sample, N_d is the concentration of charge carriers, V_a is the applied potential, V_{fb} is the flat band potential, k is Boltzmann constant, and T is temperature.

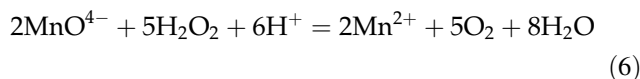
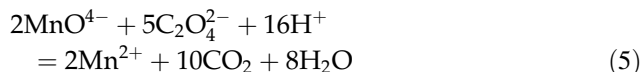
To investigate whether the photocurrents on $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film photoanode originated from the water oxidation, the Faraday efficiency of O_2 evolution $[\eta(\text{O}_2)]$ was measured in a single gas-tight cell at 1.23 V versus RHE. Prior to measurement, the solution (0.1 M Na_2SO_4) was degassed by bubbling

Ar for 0.5 h. The amount of generated O_2 was detected using an Agilent 7890B gas chromatograph. The value of $[\eta(\text{O}_2)]$ was calculated according to Eq. (4).

$$\eta(\text{O}_2) = \left(\frac{\text{amount of generated } \text{O}_2}{\times 100 / (\text{theoretical amount of } \text{O}_2)} \right) \quad (4)$$

Titration of KMnO_4 solution measurement

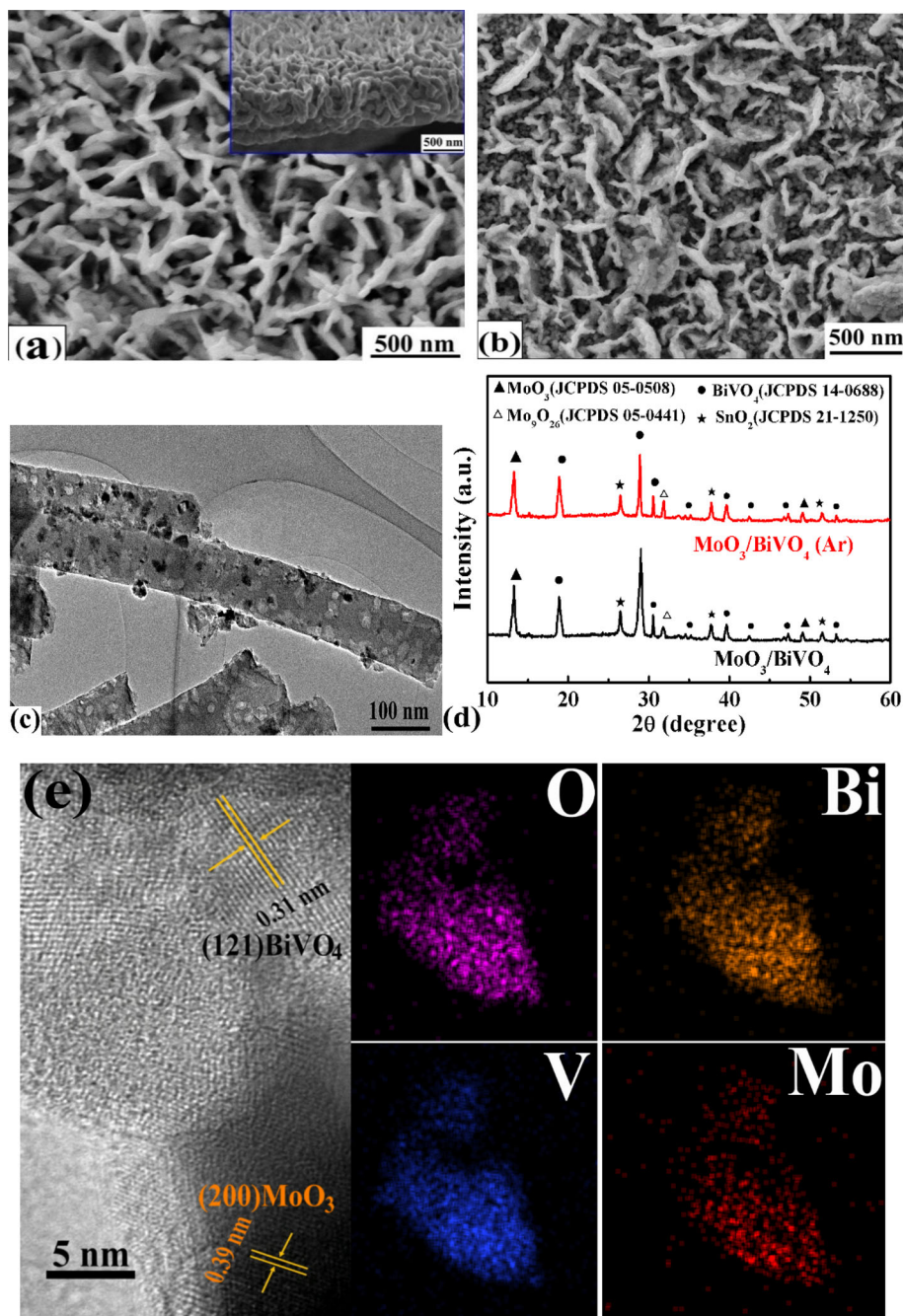
The titration of KMnO_4 solution was applied to detect the quantity of H_2O_2 that formed during PEC water oxidation. Firstly, 1 mM KMnO_4 solution was prepared and calibrated with 1 mM $\text{Na}_2\text{C}_2\text{O}_4$ solution. Secondly, 10 mL of electrolyte (0.1 M Na_2SO_4) was collected immediately after one hour of PEC stability testing and acidified with 5 mL of 3 M H_2SO_4 , and then titrated with standard KMnO_4 solution. Finally, the concentration of formed H_2O_2 was calculated on the basis of used volume of KMnO_4 standard solution. To reduce the experimental error, thrice parallel titration was carried out. The specific reaction equations related to the titration are as follows:



Results and discussion

The morphology and microstructure of the as-prepared $\text{BiVO}_4(\text{Ar})$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film were observed using SEM and TEM. As shown in Fig. 1a, the $\text{BiVO}_4(\text{Ar})$ film is composed of randomly oriented nanoflakes and the thickness of film is about 500 nm (inset of Fig. 1a). For the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film, well-distributed MoO_3 nanoparticles were coupled with the BiVO_4 nanoflakes to form $\text{MoO}_3/\text{BiVO}_4$ heterojunctions (Fig. 1b, c). From the SEM image observation for the $\text{MoO}_3/\text{BiVO}_4$ film (shown in Fig. S1), it is found that the film is of pretty similar morphology and microstructure before and after post-annealing in argon-saturated environment. Similar observations have been found in previous works related to photocatalysts with oxygen vacancies [16]. The HRTEM image shown in Fig. 1e reveals the distance of one kind of lattice fringe to be 0.31 nm, which is

Figure 1 SEM image of **a** the $\text{BiVO}_4(\text{Ar})$ and **b** $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film; **c** TEM image of the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film; **d** XRD pattern of the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film. **e** HRTEM image and EDS mapping of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film.



consistent with the interplanar spacing of the (121) planes of BiVO_4 , and the other kind of lattice fringe to be 0.39 nm which is consistent with the interplanar spacing of the (200) planes of MoO_3 . Elemental mapping shows that the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film possesses a homogeneous spatial distribution of Bi, V, O, and Mo species (Fig. 1e), which further confirms the successful formation of $\text{MoO}_3/\text{BiVO}_4$ heterojunctions. Figure 1d displays the X-ray diffraction (XRD) pattern of the as-prepared $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$

$\text{BiVO}_4(\text{Ar})$ film. As expected, the characteristic diffraction peaks of MoO_3 (JCPDS 05-0508) and BiVO_4 (JCPDS 14-0688) were observed in both $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ XRD patterns. In addition, a diffraction peak at 31.64° indexed to Mo_9O_{26} (JCPDS 05-0441) was observed in the XRD patterns. It is not surprising to find the characteristic diffraction peak of Mo_9O_{26} in MoO_3 , because MoO_3 is a typical non-stoichiometric oxide [17, 20]. Significantly, the diffraction peak of Mo_9O_{26} is more obvious

in the XRD pattern of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film compared with that in the XRD pattern of $\text{MoO}_3/\text{BiVO}_4$ film, indicating higher proportion of M_9O_{26} in $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film. Similar result was also observed in the XRD pattern of the $\text{MoO}_3(\text{Ar})$ film that post-annealed in argon-saturated environment (shown in Fig. S2), hinting oxygen deficit is more obvious in the post-annealed film.

The existence of oxygen vacancies in $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film was characterized by Raman, XPS and EPR technique. In the Raman spectra (Fig. 2a), the peak around 210 cm^{-1} is attributed to the external mode of BiVO_4 , while the peaks around 330 and 365 cm^{-1} are assigned to the asymmetric and symmetric deformation modes of the VO_4^{3-} tetrahedron ($\delta_{\text{as}}(\text{VO}_4^{3-})$ and $\delta_{\text{s}}(\text{VO}_4^{3-})$), respectively [21]. Furthermore, a peak around 825 cm^{-1} was observed, which corresponds to anti-symmetric stretching of V-O. It is noteworthy that the peak location of anti-symmetric V-O stretching for $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film was shifted to higher wave number (825 cm^{-1}) relative to the $\text{MoO}_3/\text{BiVO}_4$ film (823 cm^{-1}). In the previous reports related to BiVO_4 with oxygen vacancies, similar change on the peak of anti-symmetric V-O stretching was observed [16, 22], suggesting the existence of oxygen vacancies in $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film. Additionally, the Bi 4f and V 2p peaks in the XPS spectrum of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film both show shift to lower binding energy compared with those in $\text{MoO}_3/\text{BiVO}_4$ film (Fig. 2b, c). Such changes can be attributed to the introduction of oxygen vacancies that results in partial reduction of Bi^{3+} and V^{5+} ions. [14] Simultaneously, a shift of the Mo 3d peaks to lower binding energy was observed in the XPS spectrum of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film (Fig. 2d), confirming the presence of oxygen vacancies in MoO_3 . Furthermore, the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film was further characterized by EPR spectroscopy to detect the presence of oxygen vacancies in the film. As recorded in Fig. 2e, the EPR spectrum for $\text{MoO}_3/\text{BiVO}_4$ film and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film both shows a signal center at $g = 1.978$, which is consisted to the g value for paramagnetic V^{4+} [23].

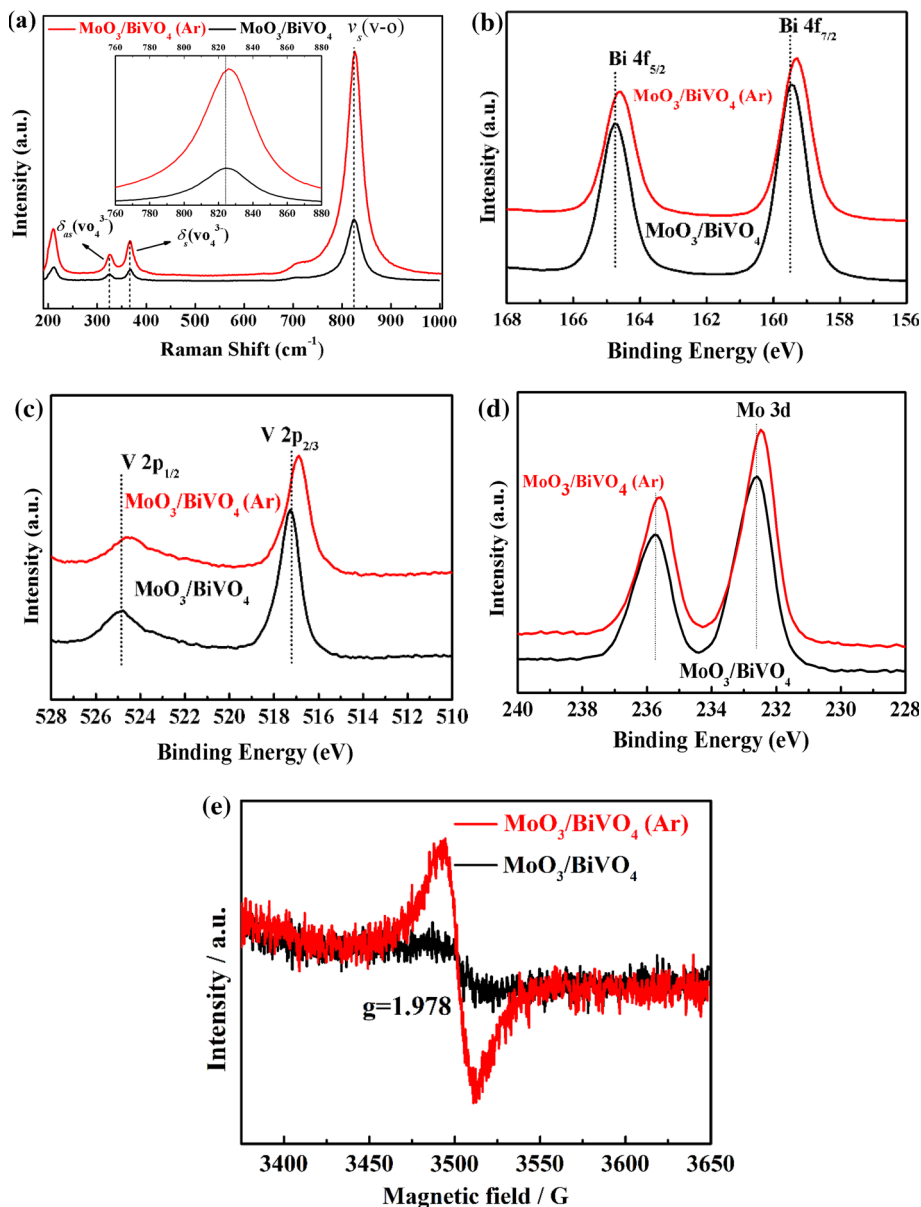
However, the EPR signal of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film shows markedly increased than that of $\text{MoO}_3/\text{BiVO}_4$ film, confirming the presence of oxygen defects in $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film [24]. According to the XRD patterns, Raman, XPS and EPR spectrum, we can conclude that the oxygen vacancies were successfully

introduced into $\text{MoO}_3/\text{BiVO}_4$ film by post-annealing the film in argon-saturated atmosphere.

To optimize the PEC activity of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film, different post-annealing temperatures and time were investigated in the argon-saturated atmosphere. The LSV measurements indicate that the $\text{MoO}_3/\text{BiVO}_4$ film post-annealed at $400\text{ }^\circ\text{C}$ for 40 min in argon-saturated atmosphere is of the optimal PEC water oxidation activity (shown in Fig. S3a and S3b). Thus, this post-annealing condition was used to treat the $\text{MoO}_3/\text{BiVO}_4$ film for subsequent investigation.

Figure 3a, b shows the LSV and i-t curves of the $\text{MoO}_3/\text{BiVO}_4$ film with and without oxygen vacancies that measured in $0.1\text{ M Na}_2\text{SO}_4$ under AM 1.5G irradiation. Both under front and back irradiation, the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film shows enhanced photocurrent density. A higher photocurrent density of 4.10 mA cm^{-2} is achieved on the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ under back irradiation at 1.1 V versus SCE, which is over 200% enhancement compared with the $\text{MoO}_3/\text{BiVO}_4$ film (1.83 mA cm^{-2}) at the same condition. The Faraday efficiency of O_2 evolution on $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film electrode is close to 100%, indicating that the photocurrent on the film is mainly originated from the PEC water oxidation (shown in Fig. S4). In addition, the onset potential of photocurrent was negatively shifted on the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film (0.03 V versus SCE) compared with the $\text{MoO}_3/\text{BiVO}_4$ film (0.23 V versus SCE), revealing its faster water oxidation kinetics. For comparison and confirmation, the PEC water oxidation activity on $\text{MoO}_3/\text{BiVO}_4(\text{O}_2)$ film that was prepared via post-annealing the $\text{MoO}_3/\text{BiVO}_4$ film in O_2 atmosphere at $500\text{ }^\circ\text{C}$ for 2 h was investigated. In general, the $\text{MoO}_3/\text{BiVO}_4(\text{O}_2)$ film is of similar activity as the $\text{MoO}_3/\text{BiVO}_4$ film (see in Fig. S3d), both lower than that of the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film. Besides, higher photocurrent was observed on the MoO_3 and BiVO_4 film with oxygen vacancies (Fig. S5), further demonstrating the positive effect of oxygen vacancies on the water oxidation activity of photoanode. To clarify the role of oxygen vacancies, the charge separation and injection efficiency of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ and $\text{MoO}_3/\text{BiVO}_4$ film were quantitatively evaluated based on the LSV measurements in a hole scavenger (Na_2SO_3) containing solution (see Fig. S6) and the absorbed photon flux of films (see Fig. 5c). In comparison with the $\text{MoO}_3/\text{BiVO}_4$ film, higher charge separation and injection efficiency were achieved on the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film (Fig. 3c, d). The charge separation

Figure 2 **a** Raman spectra of the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film. High-resolution XPS spectra of the **b** Bi 4f, **c** V 2p and **d** Mo 3d obtained from the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film. **e** EPR spectra of the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film.



and injection efficiency on the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film are, respectively, 34.5% and 72.0% at 1.23 V versus RHE, while those on the $\text{MoO}_3/\text{BiVO}_4$ film are 30.0% (separation efficiency) and 46.0% (injection efficiency), respectively. It is generally accepted that the charge-injection efficiency of photoanode is related to its surface reaction kinetics. Comparatively speaking, the charge-injection efficiency for the $\text{MoO}_3/\text{BiVO}_4$ film with oxygen vacancies is particularly improved, indicating that the oxygen vacancies have more obvious influence on the water oxidation kinetics of $\text{MoO}_3/\text{BiVO}_4$ film.

The influence of oxygen vacancies on the PEC water oxidation kinetics of $\text{MoO}_3/\text{BiVO}_4$ photoanode

was investigated by electrochemical impedance spectroscopy (EIS). As shown in Fig. 4a, two slightly depressed semicircles are observed in the Nyquist plots that measured on the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film electrode under irradiation. It is well known that the arc of semicircle in this typical Nyquist plot is relevant to the charge separation and transfer kinetics at electrode/electrolyte interface [25]. The semicircle arcs of $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film electrode are much smaller than those of $\text{MoO}_3/\text{BiVO}_4$ film electrode, suggesting faster charge separation and transfer kinetics during PEC water oxidation. The equivalent circuit in the light of measured impedance data was shown in Fig. 4b. In the

Figure 3 **a** LSV scans and **b** amperometric *i*-*t* curves for the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film in 0.1 M Na₂SO₄ under illumination with 100 mW/cm² simulated solar light. Calculated charge separation **c** and injection **d** efficiency of MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film.

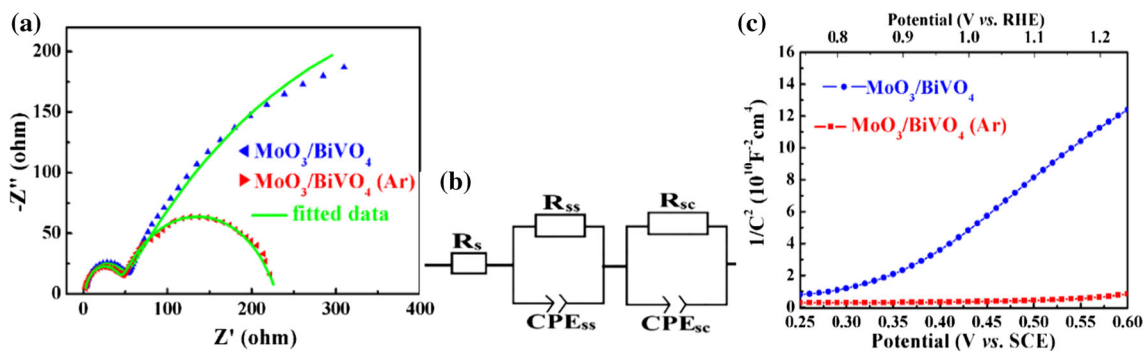
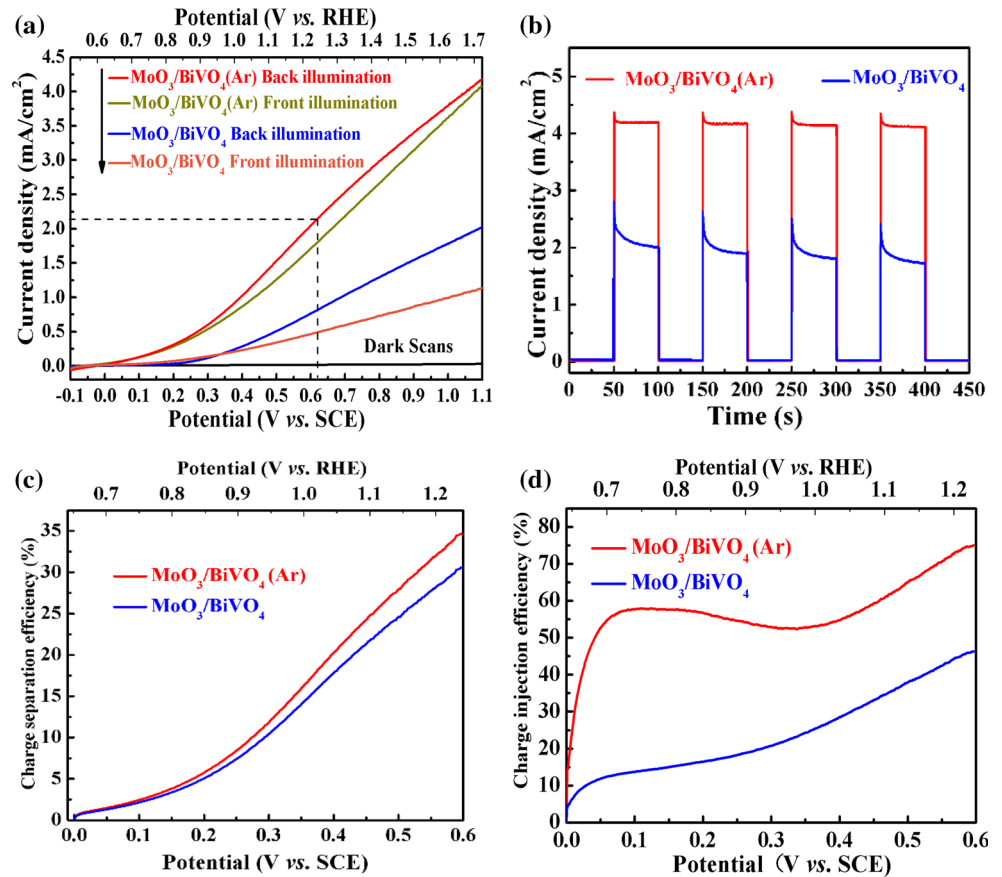


Figure 4 **a** Nyquist plots of the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film electrode. The EIS measurements were performed in 0.1 M Na₂SO₄ at 1.23 V versus RHE under 100 mW/cm² simulated solar light illumination. The solid line in Fig. 4a is the fitted data from Zview software using the proposed

equivalent circuit, R_s represents the resistance of solution, R_{ss} is the surface state resistance related to the charge transfer from the valence band or conduction band to the surface of semiconductor electrode [25], R_{sc} is the space charge separation resistance [18], and CPE_{ss} and CPE_{sc} are the constant phase elements for the electrolyte/electrode interface

equivalent circuit model. **b** An equivalent circuit for the film electrode. **c** Mott–Schottky plots for the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film electrode in 0.1 M Na₂SO₄ at a frequency of 1000 Hz under AM 1.5G illumination.

and electrode surface, respectively. The fitted values of R_{sc} and R_{ss} for the MoO₃/BiVO₄(Ar) film electrode are 30.45 Ω and 186.5 Ω , respectively, which are much lower than those for the MoO₃/BiVO₄ film electrode (R_{sc} : 49.21 Ω ; R_{ss} : 894.9 Ω , shown in Table 1). The EIS result demonstrates that the MoO₃/BiVO₄ film with oxygen vacancies has faster interfacial

charge transfer and separation rate during PEC water oxidation. Figure 4c shows the Mott–Schottky plots for the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film electrode in 0.1 M Na₂SO₄ under 100 mW/cm² simulated solar light irradiation. Positive slope was observed in the Mott–Schottky plots for both MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film electrode, showing typical feature of n-type semiconductor. In comparison with the MoO₃/BiVO₄ film electrode, the MoO₃/BiVO₄(Ar) film electrode shows a lower slope in its Mott–Schottky plot. From the SEM observations, we know that the MoO₃/BiVO₄ film both with and without oxygen vacancies has similar morphology and microstructure (see Fig. S1). Under the same measurement conditions, the slope of Mott–Schottky plot is inversely proportional to the charge carrier density of film electrode (see the Mott–Schottky equation in *Experimental section*) [26, 27]. Accordingly, it can infer that the MoO₃/BiVO₄ film with oxygen vacancies is of higher charge density than the normal MoO₃/BiVO₄ film under irradiation.

The above results suggest that the introduction of oxygen vacancies improves the PEC water oxidation activity of MoO₃/BiVO₄ film obviously. To investigate the relation between the PEC activity and the wavelength of the incident light quantitatively, incident photon-to-current conversion efficiency (IPCE) measurements were taken for the films. Figure 5a is the IPCE spectrum for the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film that measured in 0.1 M Na₂SO₄ at 1.23 V versus RHE. For both the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) films, the photoresponse ranges are observed from 320 to 520 nm, which are consistent with their UV–Vis absorption spectrum (Fig. 5b). However, the MoO₃/BiVO₄(Ar) shows higher IPCE than the MoO₃/BiVO₄ film, further confirming their PEC activity difference. The photocurrent density of MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film was, respectively, integrated to 0.78 mA/cm² and 2.02 mA/cm² using their IPCE spectrum data, which are close to the photocurrent value from their LSV results (the data shown in Table S1). Significantly, the

MoO₃/BiVO₄ film has similar optical absorption behavior regardless of oxygen vacancies (Fig. 5b). Based on the absorbed photon flux spectra (Fig. 5c), the total absorbed photocurrents of MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film are integrated to be 5.91 mA cm⁻² and 6.01 mA cm⁻², respectively. Combined with the PEC activity results and optical absorption spectra, it can be concluded that the dramatically enhanced PEC water oxidation activity on MoO₃/BiVO₄(Ar) film cannot be caused by the slight difference of light absorption.

For the water oxidation on photoanode, the stability is an important parameter to estimate the performance of photoanode. Figure 6a shows the PEC stability curve of the MoO₃/BiVO₄ and MoO₃/BiVO₄(Ar) film in 0.1 M Na₂SO₄ at 1.23 V versus RHE. For the MoO₃/BiVO₄ film, the photocurrent density drops from 0.63 mA cm⁻² to 0.14 mA cm⁻² after 10000 s of irradiation. The PEC activity decay of MoO₃/BiVO₄ film is mainly ascribed to the anodic photocorrosion that originated from the photooxidation-coupled dissolution of V⁵⁺ on the BiVO₄ film. As a contrast, stable photocurrent (~ 2.0 mA cm⁻²) was obtained on the MoO₃/BiVO₄(Ar) film under a longer irradiation time of 18000 s. It is necessary to point out that the PEC activity on MoO₃/BiVO₄ (Ar) film shows decreased trend when in excess of 5 h reaction. However, about 90% PEC activity can be recovered by re-annealing the MoO₃/BiVO₄ (Ar) film at 400 °C for 40 min in argon-saturated atmosphere (MoO₃/BiVO₄ (Ar) 2nd cycle in Fig. 6a). After the PEC stability testing, the concentration of V in Na₂SO₄ solution which was used as electrolyte for PEC stability testing was detected by ICP technique. As shown in Table 2, the concentration of V is 3.28 μM in the Na₂SO₄ solution which was used for the MoO₃/BiVO₄ film stability testing, confirming that the attenuation of PEC activity is initiated by V⁵⁺ dissolving. A lower V concentration of 0.90 μM was detected in the MoO₃/BiVO₄(Ar) film that used Na₂SO₄ solution. Additionally, we further detected the concentration of H₂O₂ that may be formed

Table 1 The values of the elements in equivalent circuit fitted in the Nyquist plots of Fig. 4a

Sample	Rs/Ω (Error/ %)	Rsc/Ω (Error/ %)	CPEsc-P (Error/%)	CPEsc-T/F (Error/%)	Rss/Ω (Error/ %)	CPEss-P (Error/%)	CPEss-T/F (Error/%)
MoO ₃ /BiVO ₄	2.023 (4.32)	49.21 (3.93)	2.47E−4 (2.33)	3.494E−7 (4.12)	894.9 (2.54)	0.6115 (1.81)	2.102E−4 (5.45)
MoO ₃ / BiVO ₄ (Ar)	2.0324 (3.67)	30.45 (1.32)	3.72E−4 (1.67)	4.587E−7 (3.51)	186.5 (1.25)	0.7619 (1.10)	9.478E−5 (4.88)

Figure 5 **a** IPCE spectra of the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film in 0.1 M Na_2SO_4 at 1.23 V versus RHE. **b** UV–Vis absorbance spectra and **c** absorbed photon flux of the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film.

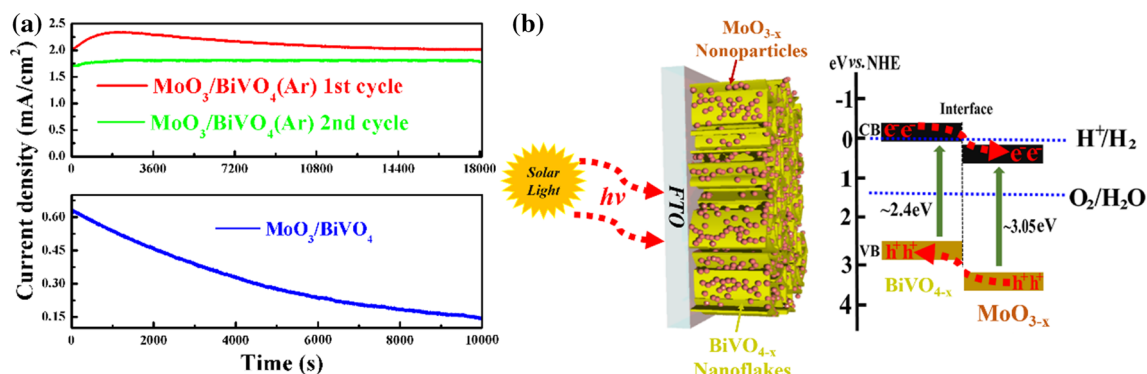
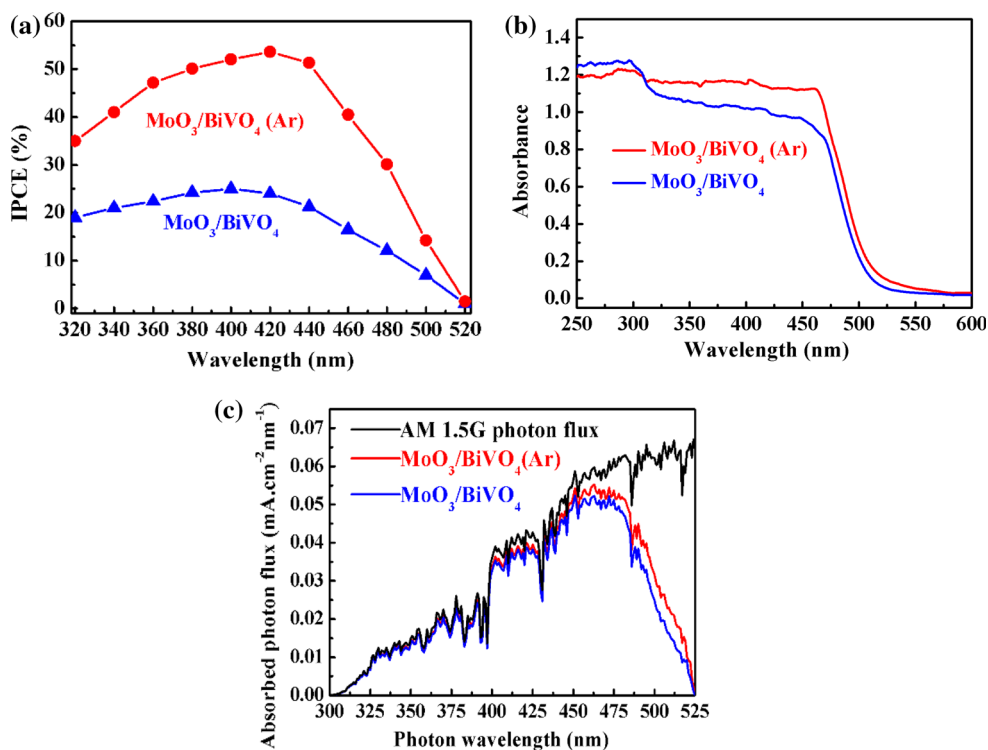


Figure 6 **a** Photocurrent density versus time curves for the $\text{MoO}_3/\text{BiVO}_4$ and $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film in 0.1 M Na_2SO_4 at 1.23 V versus RHE. **b** Schematics of charge transfer and separation on the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film.

through a two-electron pathway on the films during PEC stability testing [28]. After 3600 s of PEC stability testing, 10 mL of 0.1 M Na_2SO_4 electrolyte was sampled immediately for KMnO_4 titration to detect the concentration of H_2O_2 . The concentration of H_2O_2

Table 2 The ICP results of dissolved concentration of V in 0.1 M Na_2SO_4 that used for stability testing of the films

Sample	Concentration of V (μM)
$\text{MoO}_3/\text{BiVO}_4$	3.28
$\text{MoO}_3/\text{BiVO}_4(\text{Ar})$	0.90

from the electrolyte that was used for $\text{MoO}_3/\text{BiVO}_4$ film PEC stability testing is $6.53 \mu\text{M}$, and for the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film is $2.24 \mu\text{M}$ (Table 3), revealing weaker H_2O_2 formation on the $\text{MoO}_3/\text{BiVO}_4(\text{Ar})$ film and thus weaker anodic photocorrosion. Actually, the anodic photocorrosion rate of BiVO_4 was influenced by its interfacial charge transfer and surface recombination rate [7, 10]. The degree of BiVO_4 anodic photocorrosion can be kinetically suppressed through the improvement of its interfacial charge transfer rate. Combined with PEC results above (the charge separation and injection efficiency and EIS), it can be reasonably inferred that the $\text{MoO}_3/\text{BiVO}_4$ film

Table 3 The formed concentration of H₂O₂ in 0.1 M Na₂SO₄ that used for PEC stability testing of the films

Sample	Concentration of H ₂ O ₂ (μM)
MoO ₃ /BiVO ₄	6.53
MoO ₃ /BiVO ₄ (Ar)	2.24

with oxygen vacancies is capable of restraining the anodic photocorrosion of BiVO₄, because of its improved interfacial charge transfer and surface charge separation rate.

The flat band potential of MoO₃(Ar) and BiVO₄(Ar) was, respectively, determined to be 0.56 V versus RHE and 0.06 V versus RHE by Mott–Schottky measurement (shown in Fig.S7a and 7b). Based on the semi-empirical theory that the conduction band potential of n-type semiconductors is often more negative by about 0.1 V than its flat band potential [29], the conduction band potential of MoO₃(Ar) and BiVO₄(Ar) is inferred to be 0.46 V versus RHE and -0.04 V versus RHE, respectively. Meanwhile, the band gap of MoO₃(Ar) film is determined to be 3.05 eV (see Fig.S7c and 7d). On the basis of results obtained above, a possible mechanism for the improved PEC water oxidation performance on the MoO₃/BiVO₄(Ar) film was proposed (Fig. 6b). For the MoO₃/BiVO₄ film with oxygen vacancies, effective heterojunctions are formed at MoO_{3-x}/BiVO_{4-x} interface through their physical coupling and band potentials matching. Under irradiation with solar light, the photo-generated electrons and holes on BiVO_{4-x} surface are orderly separated and transferred. Specifically, the electrons on BiVO₄ surface are transferred to MoO₃ due to the conduction band potential difference between BiVO₄ and MoO₃, while the holes physically stayed on BiVO₄ for driving the water oxidation reaction. Duo to the presence of oxygen vacancies in MoO₃ and BiVO₄, the interfacial charge transfer and separation rate were accelerated. As a result, the PEC water oxidation activity on MoO₃/BiVO₄(Ar) film was improved as well as the anodic photocorrosion was restrained.

Conclusions

In summary, oxygen vacancies were introduced into the MoO₃/BiVO₄ film photoanode to improve its PEC water oxidation activity and stability. In comparison

with MoO₃/BiVO₄ film, a higher photocurrent density of 4.1 mA/cm² was achieved on the MoO₃/BiVO₄ film with oxygen vacancies at 1.1 V versus SCE in 0.1 M Na₂SO₄. In addition, the MoO₃/BiVO₄ photoanode with oxygen vacancies shows higher water oxidation stability, without significant loss of photoactivity for 5 h reaction. The enhanced performance on such a MoO₃/BiVO₄ film can be attributed to that the oxygen vacancies accelerate the charge transfer and separation rate between film/electrolyte interface and thus improve the PEC water oxidation activity and restrain the anodic photocorrosion.

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Compliance with ethical standards

Conflicts of interest The authors declare that they have no conflicts of interest.

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References

- [1] Tan HL, Amal R, Ng YH (2017) Alternative strategies in improving the photocatalytic and photoelectrochemical activities of visible light-driven BiVO₄: a review. *J Mater Chem A* 5:16498–16521
- [2] Jia Q, Iwashina K, Kudo A (2012) Facile fabrication of an efficient BiVO₄ thin film electrode for water splitting under visible light irradiation. *Proc Natl Acad Sci* 109:11564–11569
- [3] Walsh A, Yan Y, Huda MN, Al-Jassim MM, Wei SH (2009) Band edge electronic structure of BiVO₄: elucidating the role of the bis and Vd orbitals. *Chem Mater* 21:547–551
- [4] Kim TW, Choi KS (2014) Nanoporous BiVO₄ photoanodes with dual-layer oxygen evolution catalysts for solar water splitting. *Science* 343:990–994

- [5] Chen Z, Jaramillo TF, Deutsch TG, Kleiman-Shwarscstein A, Forman AJ, Gaillard N, Garland R, Takanabe K, Heske C, Sunkara M (2010) Accelerating materials development for photoelectrochemical hydrogen production: standards for methods, definitions, and reporting protocols. *J Mater Res* 25:3–16
- [6] Zhao Z, Li Z, Zou Z (2011) Electronic structure and optical properties of monoclinic clinobisvanite BiVO_4 . *Phys Chem Chem Phys* 13:4746–4753
- [7] Lee DK, Choi KS (2018) Enhancing long-term photostability of BiVO_4 photoanodes for solar water splitting by tuning electrolyte composition. *Nat Energy* 3:53–60
- [8] Park HS, Kweon KE, Ye H, Paek E, Hwang GS, Bard AJ (2011) Factors in the metal doping of BiVO_4 for improved photoelectrocatalytic activity as studied by scanning electrochemical microscopy and first-principles density-functional calculation. *J Phys Chem C* 115:17870–17879
- [9] Luo W, Yang Z, Li Z, Zhang J, Liu J, Zhao Z, Wang Z, Yan S, Yu T, Zou Z (2012) Solar hydrogen generation from seawater with a modified BiVO_4 photoanode. *Energy Environ Sci* 4:4046–4051
- [10] Seabold JA, Choi KS (2012) Efficient and stable photo-oxidation of water by a bismuth vanadate photoanode coupled with an iron oxyhydroxide oxygen evolution catalyst. *J Am Chem Soc* 134:2186–2192
- [11] Abdi FF, Krol R (2012) Nature and light dependence of bulk recombination in Co-Pi catalyzed BiVO_4 photoanodes. *J Phys Chem C* 116:9398–9404
- [12] Rao PM, Cai L, Liu C, Cho IS, Lee CH, Weisse JM, Yang P, Zheng X (2014) Simultaneously efficient light absorption and charge separation in $\text{WO}_3/\text{BiVO}_4$ core/shell nanowire photoanode for photoelectrochemical water oxidation. *Nano Lett* 14:1099–1105
- [13] Eisenberg D, Ahn HS, Bard AJ (2014) Enhanced photoelectrochemical water oxidation on bismuth vanadate by electrodeposition of amorphous titanium dioxide. *J Am Chem Soc* 136:14011–14014
- [14] Wang G, Yang Y, Han D, Li Y (2017) Oxygen defective metal oxides for energy conversion and storage. *Nano Today* 13:23–39
- [15] Abdi FF, Savenije TJ, May MM, Dam B, van de Krol R (2013) The origin of slow carrier transport in BiVO_4 thin film photoanodes: a time-resolved microwave conductivity study. *J Phys Chem Lett* 4:2752–2757
- [16] Wu JM, Chen Y, Pan L, Wang P, Cui Y, Kong DC, Wang L, Zhang X, Zou JJ (2018) Multi-layer monoclinic BiVO_4 with oxygen vacancies and V^{4+} species for highly efficient visible-light photoelectrochemical applications. *Appl Catal B Environ* 221:187–195
- [17] Balendhran S, Deng J, Ou JZ, Walia S, Scott J, Tang J, Wang KL, Field MR, Russo S, Zhuiykov S, Strano MS, Medhekar N, Sriram S, Bhaskaran M, Kalantar-zadeh K (2013) Enhanced charge carrier mobility in two-dimensional high dielectric molybdenum oxide. *Adv Mater* 25:109–114
- [18] He H, Zhou Y, Ke G, Zhong X, Yang M, Bian L, Lv K, Dong F (2017) Improved surface charge transfer in $\text{MoO}_3/\text{BiVO}_4$ heterojunction film for photoelectrochemical water oxidation. *Electrochim Acta* 257:181–191
- [19] He H, Berglund SP, Rettie A, Chemelewski W, Xiao P, Zhang Y, Mullins CB (2017) Synthesis of BiVO_4 nanoflake array films for photoelectrochemical water oxidation. *J Mater Chem A* 24:9371–9379
- [20] Bouzidi A, Benramdane N, Tabet-Derraz H, Mathieu C, Khelifa B, Desfeux R (2003) Effect of substrate temperature on the structural and optical properties of MoO_3 thin films prepared by spray pyrolysis technique. *Mater Sci Eng, B* 97:5–8
- [21] Yoon H, Mali MG, Choi JY, Kim MW, Choi SK, Park H, Al-Deyab SS, Swihart MT, Yarin AL, Yoon SS (2015) Nanotextured pillars of electrosprayed bismuth vanadate for efficient photoelectrochemical water splitting. *Langmuir* 31:3727–3737
- [22] Tan H, Suyanto A, De Denko AT, Saputera WH, Amal R, Osterloh FE, Ng Y (2017) Enhancing the photoactivity of faceted BiVO_4 via annealing in oxygen-deficient condition. *Part Part Syst Charact* 34:1600290
- [23] Zapart MB, Zapart W, Wyslocki B, Zhukov AP (1988) EPR of V^{4+} ions in SbVO_4 . *Ferroelectrics* 80:55–58
- [24] Zheng JY, Lyu HY, Xie C, Wang RL, Tao L, Wu HB, Zhou HJ, Jiang SP, Wang SY (2018) Defect-enhanced charge separation and transfer within protection layer/semiconductor structure of photoanodes. *Adv Mater* 30:1801773
- [25] Bohra D, Smith WA (2015) Improved charge separation via Fe-doping of copper tungstate photoanodes. *Phys Chem Chem Phys* 17:9857–9866
- [26] Parmar KPS, Kang HJ, Bist A, Dua P, Jang JS, Lee JS (2012) Photocatalytic and photoelectrochemical water oxidation over metal-doped monoclinic BiVO_4 photoanodes. *Chemosuschem* 5:1926–1934
- [27] Ma M, Zhang K, Li P, Jung MS, Jeong MJ, Park JH (2016) Dual oxygen and tungsten vacancies on a WO_3 photoanode for enhanced water oxidation. *Angew Chem Int Ed* 128:11998–12002
- [28] Fuku K, Miyase Y, Miseki Y, Funaki T, Gunji T, Sayama K (2017) Photoelectrochemical hydrogen peroxide production from water on a $\text{WO}_3/\text{BiVO}_4$ photoanode and from O_2 on an Au cathode without external bias. *Chem Asian J* 12:1111–1119
- [29] Matsumoto Y, Omae M, Sato E, Watanabe I (1986) Photoelectrochemical properties of the Zn-Ti-Fe spinel oxides. *J Electrochem Soc* 133:711–716